

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Attn: APPLICATION BRANCH**  
Hiroaki INOUE et al. : Attorney Docket No. 2004\_0144  
Serial No. NEW :  
Filed February 10, 2004 :

ELECTROLESS PLATING LIQUID AND  
SEMICONDUCTOR DEVICE  
**(Rule 1.53(b) Divisional  
of Serial No. 09/880,005,  
Filed June 14, 2001)**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
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ACCOUNT NO. 23-0975

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**CLAIM OF PRIORITY UNDER 35 USC 119**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

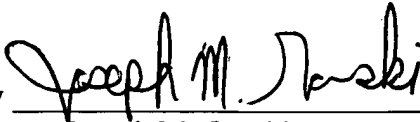
Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2001-167355, filed June 1, 2001, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/880,005, filed June 14, 2001.

Respectfully submitted,

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